



Patent
257/040
P00-0022

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Bryer, James

Serial No.: 09/658,395

Filed: September 8, 2000

For: SPRAY NOZZLE SYSTEM FOR A
SEIMICONDUCTOR WAFER CONTAINER
CLEANING APPARATUS

) Group Art Unit: 1746

) Examiner: Zeinab El-Arini

8/13/02

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AMENDMENT AND RESPONSE

Box AMENDMENT
Commissioner for Patents
Washington, D.C. 20231

Sir:

In reply to the February 8, 2002 Office Action, please amend the above-identified application as follows:

IN THE SPECIFICATION

Please amend the Specification as follows:

LA-229340.1

CERTIFICATE OF MAILING
(37 C.F.R. §1.8a)

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I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to the Box Fee Amendment, Commissioner for Patents, Washington, D.C. 20231.

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